

<b>Notice of References Cited</b>	Application/Control No. 10/792,176	Applicant(s)/Patent Under Reexamination CHAIT ET AL.	
	Examiner Cybille Delacroix-Muirheid	Art Unit 1614	Page 1 of 1


**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,750,061	06-2004	Chait et al.	436/89
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	K	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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